

P2001,0356

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Torsten Seidel et al.
Applic. No. : 10/715,073 Confirmation No. 3310
Filed : November 17, 2003
Title : CONFIGURATION AND METHOD FOR DETECTING
DEFECTS ON A SUBSTRATE IN A PROCESSING TOOL
Examiner : Brian Q. Le
Group Art Unit: 2624
Docket No. : P2001,0356
Customer No. : 24131

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

A M E N D M E N T

S i r :

Responsive to the Office action dated July 16, 2008 kindly
amend the above-identified application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.